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<b>TRANSMITTAL FORM</b> <i>(to be used for all correspondence after initial filing)</i>	Application Number	09/598,304
	Filing Date	06/21/2000
	First Named Inventor	Ata et al.
	Group Art Unit	1762
	Examiner Name	Chen, Bret
Total Number of Pages in This Submission	Attorney Docket Number	09793822-0013

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Docket No. 09793822-0013

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of:  
Ata et al.

Serial No.: 09/598,304

Filed: June 21, 2000

For: **CARBONACEOUS COMPLEX  
STRUCTURE AND  
MANUFACTURING METHOD  
THEREFOR**

Examiner: Chen, Bret

Group Art Unit: 1762

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AMENDMENT "B"

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

In response to the Office Action mailed February 13, 2003, please consider the following amendments and remarks.

In the claims:

Please cancel claim 13, ~~15-17~~, 19, 22, and 23 without prejudice.

Please amend claims 12, 17, and 21 as follows:

C1 12. (twice amended) A method for manufacturing a carbonaceous complex structure comprising:

a step of forming a carbonaceous thin film on a smooth surface of a substrate and  
a step of forming a fullerene polymer film on said thus formed carbonaceous thin film.

C2 17. (twice amended) The method for manufacturing a carbonaceous complex structure according to claim 12 further comprising the step of